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K. Duncan
3/19/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: TSUTOMU YAMADA ET AL.

SERIAL NO.: 09/966,692

FILED: September 28, 2001

FOR: METHOD OF ATTACHING LAYER
MATERIAL AND FORMING LAYER
IN PREDETERMINED PATTERN ON
SUBSTRATE USING MASK) Group Art Unit: 2812
)
) Before the Examiner:
) S. Mulpuri
)AMENDMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 24, 2003, Applicants request reconsideration in view of the following amendment and remarks for entry in the above-identified application.

I hereby certify that this correspondence was mailed via First Class Mail and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on	
December 19, 2003 (Date of Deposit)	
Agatha Skierkowski (Name of Person Mailing Paper)	
Signature <i>Agatha Skierkowski</i>	Date 12/19/03

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